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IN THE UNITED STATES PATENT AND TRADEMARK OFFICES



In re: the Application of: )  
NISHIMOTO et al )  
Serial Number: 08/897,839 )  
Filed: July 27, 1997 )  
For: STRESS-ADJUSTED INSULATING )  
FILM FORMING METHOD, SEMI- )  
CONDUCTOR DEVICE AND )  
METHOD OF MANUFACTURING )  
THE SAME )

Group Art Unit:

Examiner:

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INFORMATION DISCLOSURE STATEMENT UNDER 37 CFR 1.97(b)(3)

Commissioner of Patents  
and Trademarks  
Washington, D.C. 20231

Sir:

It is respectfully requested that the examiner consider and cite of record the five references listed on the attached, copies of which are enclosed herewith. Also enclosed herewith is a copy of an EPO search report issued June 17, 1998 in connection with EP Application No. 97112763.4-2203, believed to correspond to the captioned U.S. application, by which the five references submitted here were brought to applicant's attention.

Respectfully Submitted,

George A. Loud  
Reg. No. 25,814

Dated: July 27, 1998

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